

Electronic Acknowledgement Receipt

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Title of Invention:	SYSTEM AND METHOD FOR MONITORING SEMICONDUCTOR PRODUCTION APPARATUS
First Named Inventor/Applicant Name:	Shinichi Imai
Customer Number:	20277
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	060188-0578_ids.pdf	107799	no	6
Warnings:					
Information:					
This is not an USPTO supplied IDS fillable form					
2	NPL Documents	060188-0578_reasons_for_rejection.pdf	624382	no	14
Warnings:					
Information:					
3	Foreign Reference	060188-0578_JP2002-025981.pdf	991661	no	17
Warnings:					
Information:					
4	Foreign Reference	060188-0578_JP2000-252179.pdf	2059637	no	31
Warnings:					
Information:					
5	Foreign Reference	060188-0578_JP10-135091.pdf	430088	no	10
Warnings:					
Information:					
6	Foreign Reference	060188-0578_JP2000-198051.pdf	613086	no	10
Warnings:					
Information:					
7	Foreign Reference	060188-0578_JP2000-252180.pdf	489495	no	9
Warnings:					
Information:					
8	Foreign Reference	060188-0578_JP2002-110493.pdf	415320	no	8
Warnings:					
Information:					

9	Fee Worksheet (PTO-06)	fee-info.pdf	8217	no	2
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Total Files Size (in bytes):			5739685		
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